




IFW

PATENT  
Docket No. 20067/OPP040601US

**IN THE UNITED STATES PATENT  
AND TRADEMARK OFFICE**

Applicant(s):	)	I hereby certify that this paper and the
	)	documents referred to as enclosed
<b>Geon-Ook Park</b>	)	therewith are being deposited with the
	)	United States Postal Service as first
U.S. Serial No.: 10/817,096	)	class mail, postage prepaid, in an
	)	envelope addressed to Commissioner
For: "Semiconductor Device and	)	for Patents, P.O. Box 1450,
Fabrication Method Thereof"	)	Alexandria, Virginia 22313-1450 on
	)	this date:
Filed: April 2, 2004	)	
	)	<b>March 31, 2005</b>
Group Art Unit: 2811	)	
	)	
Examiner: Not yet assigned	)	
	)	Mark G. Hanley
	)	Attorney for Applicant(s)
	)	Registration No. 44,736

**STATUS LETTER**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

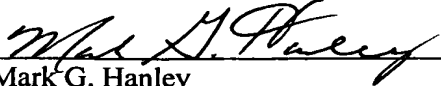
Kindly advise when an Office action can be expected in the above-referenced matter. Please note that it has been more than eight months since the last communication.

Respectfully submitted,

HANLEY, FLIGHT & ZIMMERMAN, LLC  
20 North Wacker Drive  
Suite 4220  
Chicago, Illinois 60606  
(312) 580-1020

**March 31, 2005**

By:

  
Mark G. Hanley  
Registration No.: 44,736